

Message Text

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ACTION EB-11

INFO OCT-01 CIAE-00 COME-00 DODE-00 NSAE-00 RSC-01 TRSE-00

EUR-25 AEC-11 ISO-00 MC-02 DRC-01 /052 W

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P 071050Z SEP 73

FM USMISSION OECD PARIS

TO SECSTATE WASHDC PRIORITY 568

C O N F I D E N T I A L USMISSION OECD PARIS 23636

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM, US, PL

SUBJECT: US SEMICONDUCTOR MANUFACTURING EQUIPMENT TO POLAND - IL 1355

REF: A. COCOM DOC. (73) 933 (STATE A-4433)

B. COCOM DOC. (73) 1542 (PER STATE 156064)

C. OECD PARIS 22405

1. APOLOGIZING FOR THE DELAY - ATTRIBUTABLE IN PART TO HIS
BUCKING THEM BACK TO LONDON TO CONFIRM THAT THEY WERE INDEED
NECESSARY - UKDEL CONVEYED FURTHER QUESTIONS ON REF A LATE ON
SEPTEMBER 6. HE SAID UK EXPERTS WERE STILL NOT ABLE
ADEQUATELY TO CONFIRM US CALCULATIONS PER REF B ON OUTPUT
RATE AND THEREFORE, TO ASSIST THEM IN THAT EFFORT THEY
WOULD APPRECIATE:

A. A BREAKDOWN OF ANTICIPATED PRODUCTION BY
INDIVIDUAL RECTIFIER TYPE LISTED IN APPENDIX 2, REF A, AND,

B. A DATA SHEET OR OTHER TECHNICAL SPECIFICATION OF
EACH TYPE.

2. USDEL REMONSTRATED THAT IT SEEMED RATHER LATE IN THE GAME
TO ASK FOR DATA SHEETS NOW, PARTICULARLY FOR UNEMBARGOED
DEVICES, AND REITERATED THAT SINCE EACH SLICE YIELDS BUT ONE
DEVICE, THE NEED FOR DETAILED PRODUCTION BREAKDOWN BY TYPE
SEEMED HARD TO UNDERSTAND. UK DEL RESPONDED THAT HE HAD FELT
THE SAME WAY WHEN HE HAD RECEIVED INITIAL INSTRUCTIONS SOME
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DAYS AGO AND HAD THEREFORE GONE BACK TO HIS AUTHORITIES. HE

HAD NOW BEEN ASSURED THAT UK EXPERTS CONSIDERED THE DETAILS
ESSENTIAL TO CONFIRM REF B POSITION AND FLOWED FROM THAT DOC.

3. INSTRUCTIONS REQUESTED.
ROGERS

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 JAN 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: SEMICONDUCTOR DEVICES, STRATEGIC TRADE CONTROLS
Control Number: n/a
Copy: SINGLE
Draft Date: 07 SEP 1973
Decaption Date: 01 JAN 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Authority: morefirh
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 28 MAY 2004
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1973OECDP23636
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1 ROGERS
Errors: N/A
Film Number: n/a
From: OECD PARIS
Handling Restrictions: n/a
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Legacy Key: link1973/newtext/t19730948/aaaabjnj.tel
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Page Count: 2
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Reference: A. COCOM DOC. (73) 933 (STATE A-4433,)
Review Action: RELEASED, APPROVED
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Review Comment: n/a
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Review Event:
Review Exemptions: n/a
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30 JUN 2005

Review Media Identifier:
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Review Transfer Date:
Review Withdrawn Fields: n/a
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Type: TE
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